## Crystallinity of Boron Nitride Fabricated in Various Ways

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Crystallinity of boron nitride fabricated in variety of ways has been investigated by means of X-ray diffraction. The structure of boron nitride is very similar to that of graphite<sup>1)</sup>. As is shown in graphitizing nature of carbon, the physical and chemical properties of boron nitride may vary considerably according to the nature of starting materials and the conditions of preparation. This communication describes the difference between the crystallinity of boron nitride fabricated by the gas phase reaction and that of the one prepared by the solid state reaction.

The methods of preparation of boron nitride used were as follows; (1) gas phase reaction of boron trichloride with ammonia on a SiC resistor heated at 900 or 1050°C<sup>2)</sup>, (2) decomposition at 800 or 1000°C of the complex formed by the reaction of boron trichloride with ammonia in gas phase at room temperature<sup>3)</sup>, (3) solid-gas reaction of boron oxide coated on tri-calcium phosphate with ammonia at 800 or 1000°C for four hours<sup>4)</sup>, (4) solid-gas reaction of sodium tetraborate with ammonia at 800 or 1000°C for two hours, and (5) solidsolid reaction of boron oxide with sodium amide (mixing ratio by mole, 1:3) at 800°C in nitrogen<sup>5,6)</sup>.

Interlayer spacings of (002), and La- and Lcdimensions of crystallite of boron nitride fabricated by the methods mentioned above were measured using an automatic recording X-ray spectrometer. As the observed diffraction maximum is not corrected for polarization and absorption, the true value may slightly become less than the measured one. La-dimension, the width of the graphite-like layer, was obtained from (10) band or (100) line, and Lcdimension, the thickness of the parallel packet of layers, was obtained from (002) line.

The result of X-ray measurement is summarized in Table I. The crystallinity of boron nitride fabricated at 1000°C is more developed than that at 800°C. Interlayer spacing of the

TABLE I. BORON NITRIDE FABRICATED IN A VARIETY OF WAYS

Sta	arting material	Reaction temp.	$ m  ilde{A}_{002}$	La Å	Lc Å
1)	$BCl_3\!+\!NH_3$	900 1050	3.619 3.591	45 49	12 13
2)	Decomposition of the complex (BCl <sub>3</sub> ·4NH <sub>3</sub> )	800 1000	3.624 3.594	56 68	14 14
3)	$B_{2}O_{3}\!+\!NH_{3}$	800 1000	3.389 3.339	71 290	45 66
4)	$Na_{2}B_{4}O_{7}\!+\!NH_{3}$	800 1000	3.349 3.339	265 1160	88 282
5)	$B_2O_3 + NaNH_2$	800	3.389	243	115

nitride fabricated in gas phase is larger than that of the nitride prepared in solid-gas and solid-solid reaction, while La- and Lc-dimensions. of the former being smaller than those of the latter. Boron nitrides fabricated at 800°C in the reaction of boron trichloride with ammonia and in the reaction of boron oxide on tricalcium phosphate with ammonia were heated at 1400, 1600, 1800 and 2000°C in nitrogen atmosphere of 200 mmHg. The relation between La- and Lc-dimensions of these nitride is shown with the values of starting materials in Fig. 1

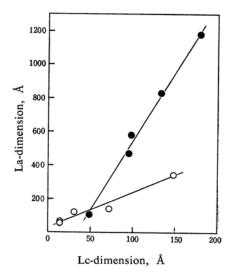


Fig. 1. Crystallite growth of boron nitride by heat treatment.

- Boron nitride fabricated by the reaction of BCl<sub>3</sub> with NH<sub>3</sub>
- Boron nitride fabricated by the reaction of B2O3 with NH3

It is shown from Fig. 1 that crystallization of boron nitride formed in solid phase is preferable to that of the nitride in gas phase. It seems that boron nitride formed by gas phase

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reaction and that prepared by solid phase one correspond to non-graphitizing and graphitizing carbons respectively.

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